Electronic Acknowledgement Receipt

EFS ID:	1257516
Application Number:	10823981
International Application Number:	
Confirmation Number:	5316
Title of Invention:	System and method for charge-balanced, continuous-write mask and wafer process for improved colinearity
First Named Inventor/Applicant Name:	Robin Lynn Almes
Customer Number:	48583
Filer:	Michael E. Noe/Robyn Pyle
Filer Authorized By:	Michael E. Noe
Attorney Docket Number:	HSJ920040029US1
Receipt Date:	17-OCT-2006
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Application Type:	Utility

Payment information:

Submitted with Payment	no

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Amendment - After Non-Final Rejection	AmendA.pdf	348334	no	4

Warnings:

Information:

| 2 | Claims | Claims.pdf | 377592 | no | 4 |

Warnings:

Information:

| | Total Files Size (in bytes): | 725926 |

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New Applications Under 35 U.S.C. 111
If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.